


<b>Search Notes</b>  	<b>Application/Control No.</b>  10567070	<b>Applicant(s)/Patent Under Reexamination</b>  VAN DUUREN, MICHEL JOS
	<b>Examiner</b>  Lappas, Jason	<b>Art Unit</b>  2827

SEARCHED			
Class	Subclass	Date	Examiner
365	210	2/22/2007	JL
365	210	6/25/2008	JL

SEARCH NOTES		
Search Notes	Date	Examiner
East	2/22/2007	JL
EAST	6/25/2008	JL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner